IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors:

Jaime Poris

Assignee:

Nanometrics Incorporated

Title:

Method of Measuring Dishing

Serial No.:

09/578,798

Filing Date:

May 23, 2000

Examiner:

William C. Choi

Group Art Unit:

2873

Docket No.:

NAN040 US

Confirmation No:

5190

Santa Clara, California August 22, 2003

COMMISSIONER FOR PATENTS P.O. BOX 1450 ALEXANDRIA VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR §1.97(c)

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, §1.97 and §1.98, the Applicants submit for consideration in the above-identified patent application the documents listed on the accompanying Form PTO-1449. A copy of the reference cited in the Other Art is provided as well. The Examiner is requested to make this document of record.

This Information Disclosure Statement is submitted pursuant to 37 CFR §1.97(c) as it is after receipt of a first Office Action on the merits but before mailing of a final Action or Notice of Allowance. Accordingly, a fee is required pursuant to 37 CFR §1.17(p). A Fee Transmittal form (PTO/SB/17) is attached to this submission.

Applicants would appreciate the Examiner initialing and returning the Form PTO-1449, indicating that the information has been considered and made of record herein.

In addition, Applicants submit for the Examiner's consideration the following list of co-pending and co-owned applications, cited by serial number, first named inventor and filing date. The Applicants presume that the Examiner has access to and will review the co-pending applications and the files thereof for any office actions, amendments or other materials that may be relevant to the patentability of the claims of the present application. For any such U.S. patent application(s) that are currently pending, the Applicants further presume

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Application No. 09/578,798

that the Examiner will consider any future office actions, amendments or other materials in the file thereof that may be relevant to the patentability of the claims herein. If the Applicants' understanding in this regard is not correct, please notify the undersigned so that copies of any such documents can be submitted to the Examiner with the necessary precautions so that the file may be expunged of any proprietary information that is considered unimportant to a reasonable examiner.

All of the co-pending applications in the following list are unpublished. Applicants do not believe that it is proper for any of the listed applications to appear on the face of a patent that may issue from the present application, and accordingly, Applicants have not listed these applications on a PTO-Form 1449.

	Serial No.:	First Named Inventor	Date:
1.	10/315,438	Jaime Poris	December 9, 2002
2.	09/576,756	Jaime Poris	May 23, 2000

The information contained in this Information Disclosure Statement under 37 C.F.R. §1.555 is to the best of my knowledge and is not to be construed as a representation that: (i) a complete search has been made; (ii) additional information material to the examination of this application does not exist; (iii) the information, protocols, results and the like reported by third parties are accurate or enabling; or (iv) the above information constitutes prior art to the subject invention.

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being facsimile transmitted to the U.S. Patent and Trademark Office to the fax питьет 703-872-9318 on August 22, 2003.

Attorney for Applicant(s)

Respectfully submitted,

Michael J. Halbert

Attorney for Applicant(s)

Reg. No. 40,633

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Sheet 1 of 1

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)						First Named Inventor: Group Art Unit: Examiner Name:			Jaime Poris 2873 William C. Choi													
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			U.S. Pa	atent Document	ts																	
*Examiner Initial	[Document Number	Date	Name	e	Class	Sub	class	Filing Date If Appropriate													
10,002	8.	4,512,661	Apr. 23, 1985	Claus et	: al.	356	3	51														
	9.	5,604,591	Feb. 18, 1997	Kitaga	wa	356	3	51														
	10.	6,568,290	May 27, 2003	Poris	3	73	8	66														
			Paraim	Patent Docume	ents		<u> </u>															
	Foreign Patent Documents Translati																					
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		OTHE	R ART (Including A	uthor, Title, Da	te, Pertine	nt Pages, E	.tc.)															
	OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.) 11. Malacara, Daniel et al. "Interferogram Analysis For Optical Testing" 1998, Marcel Dekker, Inc. pp. 113																					
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